Actual CTI Project : Enhancing Properties of Photocatalytically Active Titania Layers



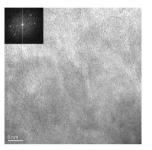
PVD: Reactive dc-sputtering at reduced pressure



PE-MOCVD: Evaporation of

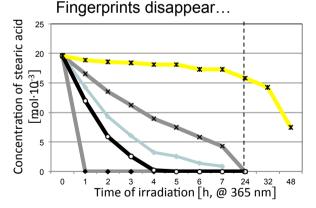
precursor in plasma reactor

Photocatalytically active titania layers have been produced by PVD magnetron sputtering and PE-MOCVD processes at room temperature and reduced pressure



HRTEM: Titania <110>

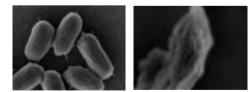




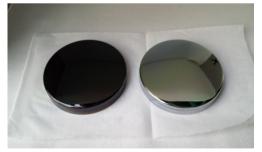
Project partners of hepia: Bodenschatz AG, Ionitec SA The nano hardness and scratch resistance of titania layers have to be improved without loosing the photo-induced benefits.

In addition, the undesired interference colours have to be reduced.

Germ-inhibiting Surfaces:



Bacteria without/with damaged hard shell



Black PVD TiO₂ layer Transparent PE-MOCVD TiO₂ on chromated sample layer on chromated sample

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CTI-project: No 16189.2 PFNM-NM

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